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|-------------------------------------|-------------------------------|--------------------------|---------------------------------|
| <b>AMENDMENT TRANSMITTAL LETTER</b> |                               |                          | Docket No.<br>M4065.0139/P139-A |
| Application No.<br>09/633,132       | Filing Date<br>August 4, 2000 | Examiner<br>E. C. H. Lee | Art Unit<br>2815                |

Applicant(s): Cem Basceri

Invention: METHOD FOR IMPROVING THE SIDEWALL STOICHIOMETRY OF THIN FILM CAPACITORS

**TO THE COMMISSIONER FOR PATENTS**

Transmitted herewith is an amendment in the above-identified application.

The fee has been calculated and is transmitted as shown below.

| CLAIMS AS AMENDED  |                                  |                                |                             |      |             |
|--|----------------------------------|--------------------------------|-----------------------------|------|-------------|
|  | Claims Remaining After Amendment | Highest Number Previously Paid | Number Extra Claims Present | Rate |             |
| Total Claims   | 19                               | - 28 =                         |                             | x    | 0.00        |
| Independent Claims   | 3                                | - 4 =                          |                             | x    | 0.00        |
| Multiple Dependent Claims (check if applicable) <input type="checkbox"/> |                                  |                                |                             |      |             |
| Other fee (please specify):  |                                  |                                |                             |      |             |
| <b>TOTAL ADDITIONAL FEE FOR THIS AMENDMENT:</b>                          |                                  |                                |                             |      | <b>0.00</b> |

- ☒ Large Entity ☐ Small Entity
- ☒ No additional fee is required for this amendment.
- ☐ Please charge Deposit Account No. \_\_\_\_\_ in the amount of \$ \_\_\_\_\_.  
A duplicate copy of this sheet is enclosed.
- ☐ A check in the amount of \$ \_\_\_\_\_ to cover the filing fee is enclosed.
- ☐ Payment by credit card. Form PTO-2038 is attached.
- ☒ The Director is hereby authorized to charge and credit Deposit Account No. 04-1073  
as described below. A duplicate copy of this sheet is enclosed.
- ☒ Credit any overpayment.
- ☒ Charge any additional filing or application processing fees required under 37 CFR 1.16 and 1.17.

*[Handwritten signature]*

Dated: November 19, 2004

Thomas J. D'Amico  
Attorney Reg. No.: 28,371

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Docket No.: M4065.0139/P139-A  
(PATENT)

**IN THE UNITED STATES PATENT AND TRADEMARK OFFICE**

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In re Patent Application of:  
Cem Basceri

Confirmation No.: 2413

Application No.: 09/633,132

Group Art Unit: 2815

Filed: August 4, 2000

Examiner: E. Lee

For: METHOD FOR IMPROVING THE  
SIDEWALL STOICHIOMETRY OF THIN  
FILM CAPACITORS

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**AMENDMENT IN RESPONSE TO NON-FINAL OFFICE ACTION**

MS: Non-Final Amendment  
Commissioner for Patents  
P.O. Box 1450  
Alexandria, VA 22313-1450

Dear Sir:

In response to the Office Action dated August 20, 2004 (Paper No. 20040808).  
Please amend the above-identified U.S. patent application as follows:

**Amendments to the Claims** are reflected in the listing of claims which begin  
on page 2 of this paper.

**Remarks** begin on page 7 of this paper.